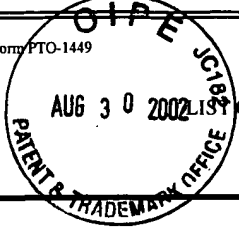



Form PTO-1449 <div style="text-align: center;">  </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1114		SERIAL NO. 09/233,377	
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U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
T8	AA	6,376,372 B1	04/23/02	Paranjpe et al.			
T8	AB	4,897,368	01/30/90	Kobushi et al.			
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	AK						

FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
AL							
AM							
AN							
AO							
AP							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
T8	AR		Omar, M. Ali, "Elementary Solid State Physics," © 1975 by Addison-Wesley Publishing Company, Inc., pages 539-542 (6 pages total).
T8	AS		Wolf, et al., "Silicon Processing for the VLSI Era - Volume 1-Process Technology," ©1986 by Lattice Press, pages 242,261, 262, 303, & 304 (7 pages total).
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EXAMINER 	DATE CONSIDERED 4/4/03
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.